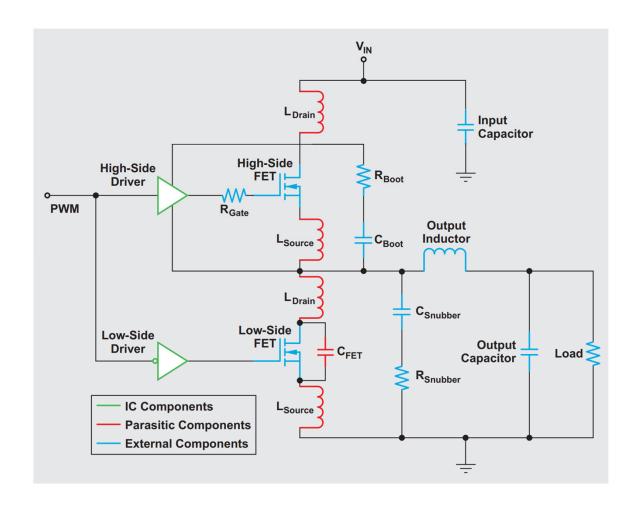
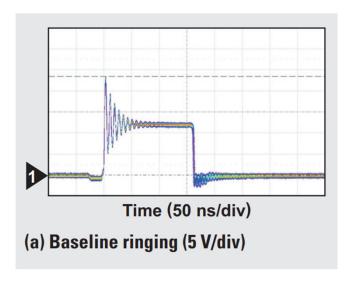
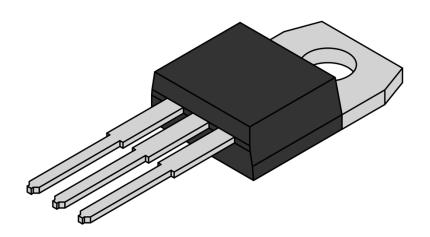
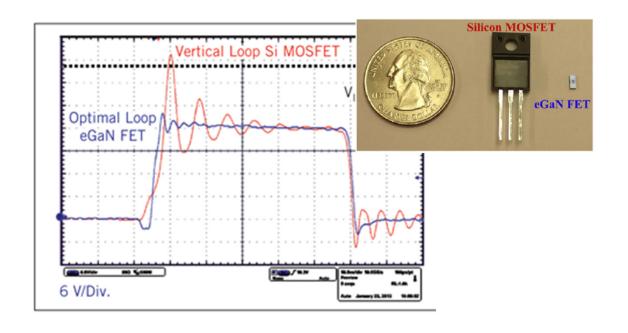
Experimental Switching Waveforms

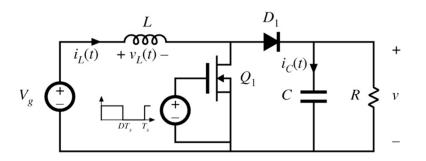




Device Packaging and Layout







The Double Pulse Test

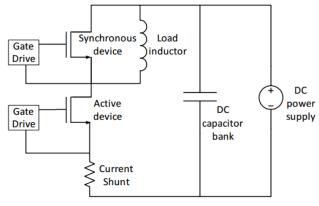


Fig. 7. Double pulse test circuit schematic.

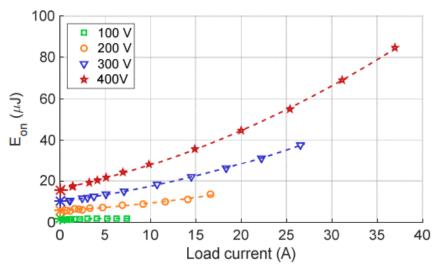
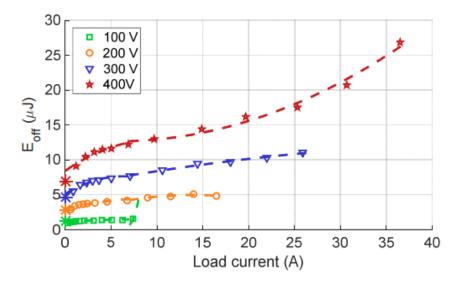
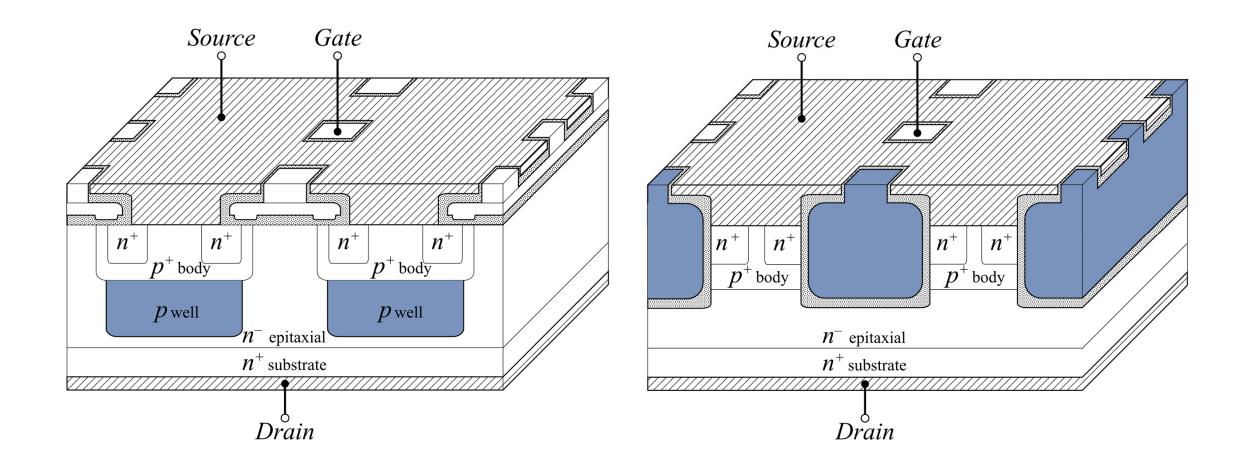


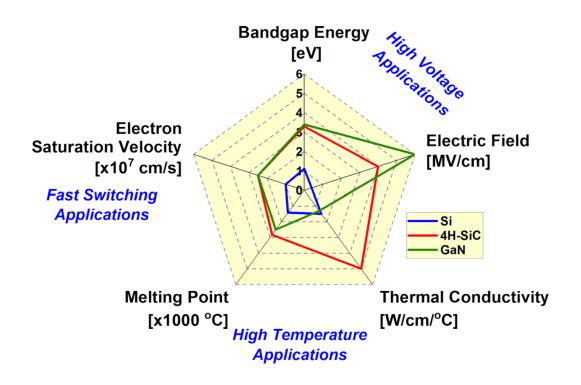
Fig. 16. Turn-on energy Eon at 25 °C.

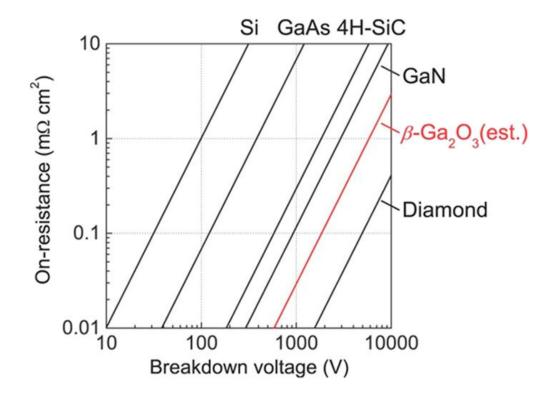


Other Device Structures

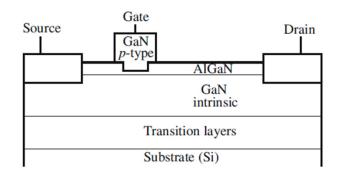


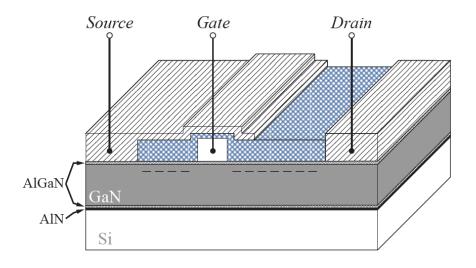
Wide Bandgap Materials





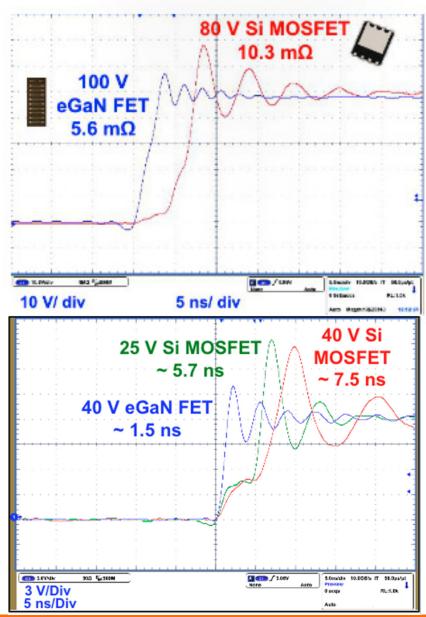
GaN HEMTs





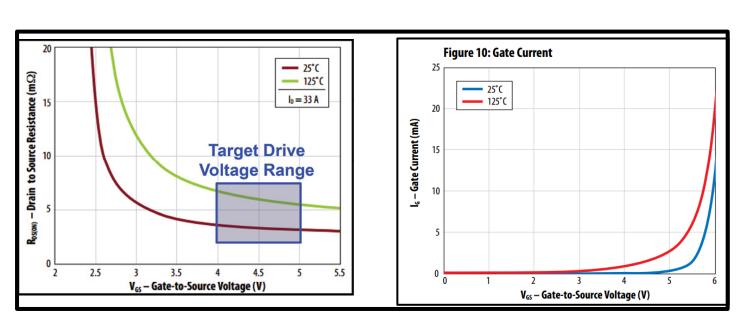
Designing with GaN

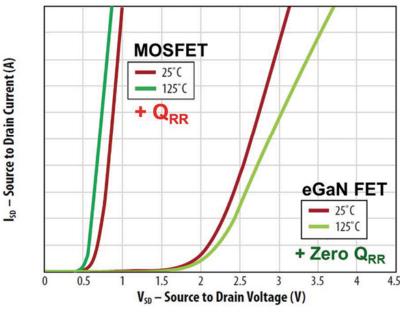
- Because of high electric breakdown field and high electron velocity, GaN devices with comparable R_{on} can be significantly smaller and switch must faster.
- Need very good layout to prevent ringing from causing overvoltage and device failure.

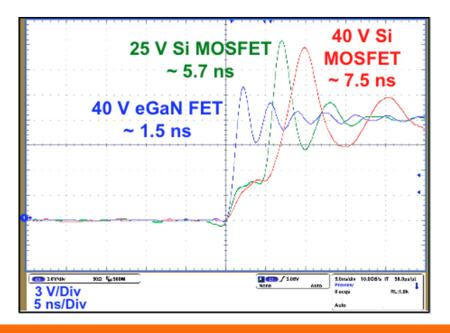


GaN Design Issues

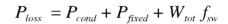
- Reverse conduction mechanism
- 2. Sensitivity to parasitics
- 3. Gate robustness
- 4. Small size -> Thermal limitations

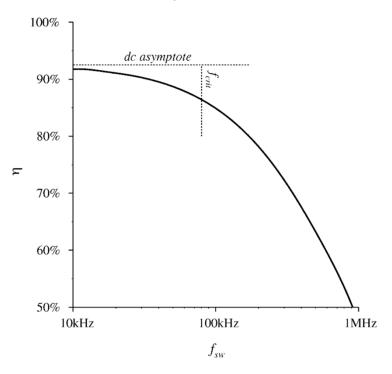




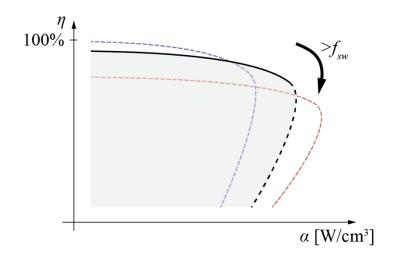


Converter Efficiency Vs. f_s

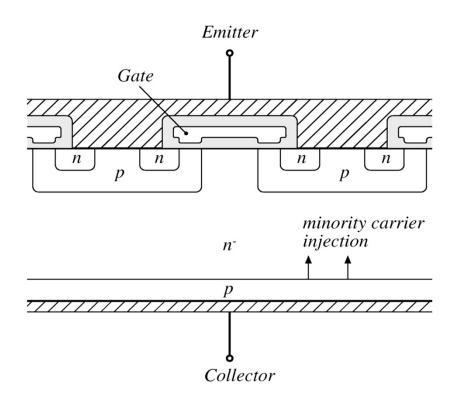




Converter Optimization

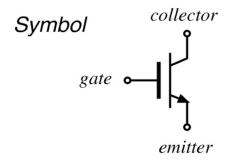


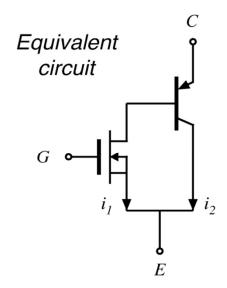
Insulated Gate Bipolar Junction Transistor



- A four-layer device
- Similar in construction to MOSFET, except extra p region
- On-state: minority carriers are injected into n⁻ region, leading to conductivity modulation
- compared with MOSFET: slower switching times, lower on-resistance, useful at higher voltages (up to 1700V)

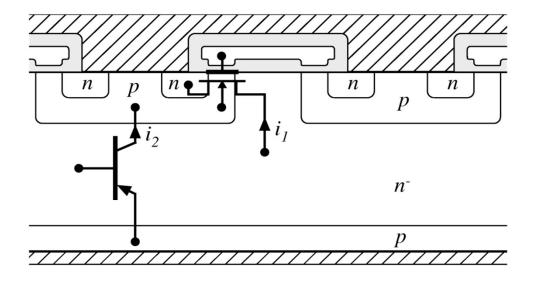
The IGBT





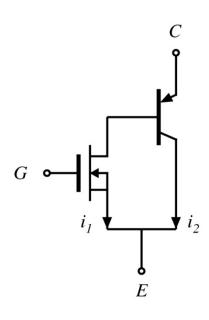
Fundamentals of Power Electronics

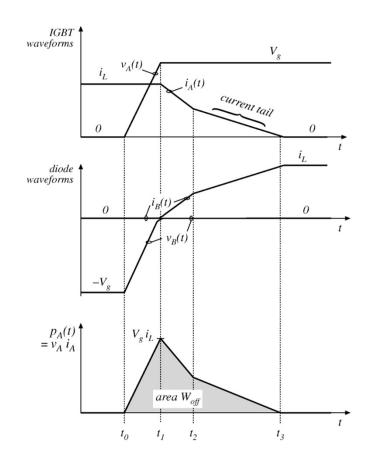
Location of equivalent devices



65

IGBT: Current Tailing





Fundamentals of Power Electronics

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Chapter 4: Switch realization